FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMENCE IP PATENT AND TRADEMARK OFFICE UST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) AUS 2 7 2001				ATTY DOCKET NO. 35.C15514	APPLICATION NO. 09/845,286		
				TADAYASU MEGURO ET AL.			
				FILING DATE May 1, 2001		GROUP 2879	
U.S. PATENT DOCUMENTS							
'EXAMINER		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING PAIR
TSP		6,208,071	3/27/01	Nishimura et al.	313	495	
TSP		4,954,744	9/4/90	Suzuki et al.	313	336	
						-	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION OR ABSTRACT
757	EP	0850892	7/98	EPO			(In English)
75.7		10-241550	9/98	Japan			Abstract and USP 6208071
FSP		8-180801	7/96	Japan			Abstract
		•				•	·
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
139		M.I. Elinson et al., "The Emission of Hot Electrons and The Field Emission of Electrons From Tin Oxide", Radio Engineering and Electronic Physics, July 1965, pp. 1290-1296.					
		H. Araki, "Electroforming and Electron Emission of Carbon Thin Films", Journal of the Vacuum, Society of Japan, 1983, pp. 22-29 (with English-language abstract on page 22).					
		G. Dittmer, "Electrical Conduction and Electron Emission of Discontinuous Thin Films", Thin Solid Films, 9, 1972, pp. 317-328.					
		M. Hartwell, "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films", IEDM, 1975, pp. 519-521.					
		C.A. Spindt, "Physical Properties of Thin-Film Emission Cathodes with Molybdenum Cones", J. Applied Physics, Vol. 47, No. 12, December 1976, pp. 5248-5263.					
TSP		J. Dyke et al., "Field Emission", Advances in Electronics and Electron Physics, Vol. VIII, 1956, pp. 89-185.					
	<u> </u>						
EXAMINER	17	HANH S.	PHAN	DATE CONSIDERED 3/8 02			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet_1_ of _1_